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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/522,569	11/17/2005	Shuhei Ogawa	033082M239	8765	
441	7590 07/06/2006		EXAM	EXAMINER	
SMITH, GAMBRELL & RUSSELL 1850 M STREET, N.W., SUITE 800			OLSEN, ALLAN W		
	DN, DC 20036		ART UNIT	PAPER NUMBER	
			1763	<u> </u>	
			DATE MAILED: 07/06/2006	DATE MAILED: 07/06/2006	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)					
	10/522,569	OGAWA ET AL.					
Office Action Summary	Examiner	Art Unit					
	Allan Olsen	1763	·····				
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the c	correspondence ad	dress -				
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING D. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period of Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tin will apply and will expire SIX (6) MONTHS from the cause the application to become ABANDONE	N. nely filed the mailing date of this of D (35 U.S.C. § 133).					
Status							
1) Responsive to communication(s) filed on 17 N	lovember 2005.						
,	action is non-final.						
	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
closed in accordance with the practice under E	Ex parte Quayle, 1935 C.D. 11, 4	53 O.G. 213.					
Disposition of Claims							
4) Claim(s) 1-13 is/are pending in the application							
4a) Of the above claim(s) is/are withdrawn from consideration.							
5) Claim(s) is/are allowed.							
•	6)⊠ Claim(s) <u>1-13</u> is/are rejected.						
7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/o	or election requirement						
o) Claim(s) are subject to restriction and/o	r election requirement.						
Application Papers							
9)☐ The specification is objected to by the Examine							
10)⊠ The drawing(s) filed on <u>17 November 2005</u> is/a			niner.				
Applicant may not request that any objection to the			-D 4 404(4)				
Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Ex							
	carminor. Note the attached Office		102.				
Priority under 35 U.S.C. § 119							
12)⊠ Acknowledgment is made of a claim for foreign	priority under 35 U.S.C. § 119(a)-(d) or (f).					
a)⊠ All b)□ Some * c)□ None of:							
1. Certified copies of the priority document		ion No					
2. Certified copies of the priority document3. Copies of the certified copies of the priority	• •		Stage				
application from the International Burea			0.290				
* See the attached detailed Office action for a list	• • • • • • • • • • • • • • • • • • • •	ed.					
Attachment(s)							
1) Notice of References Cited (PTO-892)	4) Interview Summary						
 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) 	Paper No(s)/Mail D 5) Notice of Informal F		D-152)				
Paper No(s)/Mail Date 439911/17/05. 1-28 -05	6) Other:						
S. Patent and Trademark Office							

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DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 1-13 are rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent 6,326,302 (Joubert) in view of US Patent 6,869,542 (Desphande) and further in view of US Patent 6,069,090 (Eriguchi).

Joubert teaches using an etchant comprising O2 and NH3 etch an organic layer with an overlying SiO2 hard mask.

Joubert does no teach using a Si-containing organic material as the overlying hard mask. Joubert does not teach the residence time of plasma species within the

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plasma zone. Joubert does not teach controlling the CD shift by adjusting the ratio of O2 and NH3.

Desphande teaches using a Si-containing organic material as a hard mask when etching an underlying organic material.

Eriguchi teaches that CD shift can be controlled by controlling the flow rates of plasma gases.

It would have been obvious to one skilled in the art to incorporate the hard mask of Desphande into the process of Joubert because Desphande teaches that Sicontaining hard masks sputter less readily than SiO2 and they offer tighter CD control than conventional hard masks (column 5, lines 1-57).

It would have been obvious to one skilled in the art to optimize the flow rates of O2 and NH3 according to Eriguchi and in so doing the O2 to NH3 ratio and the plasma residence time would also be optimized.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Allan Olsen whose telephone number is 571-272-1441. The examiner can normally be reached on M, W and F: 1-5.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571-272-1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Alla Olsan

Allan Olsen
Primary Examine

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